

Effect of Tetrafluorethane and Sulfur Hexafluoride Plasma Treatment on Wettability of Boron Nitride Nano-Sheets

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Boron nitride nanosheets (BNNS) consisting of 2D hexagonal boron nitride nano-layers were deposited, onto silicon substrates, via chemical vapour deposition process at 1000 °C. The BNNS were functionalized in argon plasma admixed with sulfur hexafluoride (SF₆) or tetrafluorethane (C₂H₂F₄) gases. Scanning electron microscope (SEM), High resolution transmission electron microscope (HRTEM), X-ray photoelectron spectroscopy (XPS), and Water contact angle (WCA) measurements were used to characterize the BNNS before and after plasma modification. Significant changes in the surface features, upon plasma treatments of the BNNS, were noticed during scanning and transmission electron microscopy examinations. The XPS analyses revealed an extensive surface fluorination in the case of Ar/SF₆ plasma, while formation of fluoro-carbon layer coating on the surface of BNNS was noticed in the case of Ar/C₂H₂F₄ plasma. Furthermore, the plasma treatments made BNNS super-hydrophobic with a contact angle as high as 167.9° compared to 118.2° for the untreated BNNS. The wettability of the nanostructures, as measured from the water contact angle measurements, is discussed by referring to changes in surface chemistry and morphology after plasma treatment. The stability of BNNS at high temperatures, coupled with plasma treatment can make this material a potential candidate as super-hydrophobic coating for self-cleaning application at the industrial level.

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1. Introduction

Boron nitride (BN) nanostructures are boron nitride (BN) based materials consisting of stacked hexagonal BN layers that are assembled in sheets or tubes (case of BN nano-sheets or BN nanotubes, respectively) with high aspect ratio [1–4]. These low-dimensional nanostructures are structurally identical to graphene or carbon nanotubes (CNTs) [5, 6], and exhibit many fascinating properties for advanced applications [1–9]. However, in contrast to graphene or CNTs, which are conductor or semiconductors, BN nanostructures are electrically insulator [5, 6]. This makes them a hot research topic in different applications including dielectric substrates, far-ultraviolet light-emitting, high performance electronic devices and smart coating [1–9]. Concerning smart coating, and except for some BN nanotubes which are super-hydrophobic [10, 11], the other BN nanostructures including nano-sheets [12–14], and few atomic layers [15], have shown a good hydrophobicity character (with contact angle (CA) around 100–120°). However, super super-hydrophobicity (water on a surface with a CA reaches 150°) is needed for practical application such as microelectronic, biomedical and catalysts. In addition, super hydrophobic coatings possess

an important role in anticorrosion, resisting water coalescence, and fog condensation systems [14, 16]. Super-hydrophobic surfaces are usually made of organic materials such as polymers [16], electro-deposited gold cluster films [17], porous alumina [18], dense CNT carpets [19], ZnO [20], or TiO₂ nanowires [21]. However, most of these materials do not stand high temperatures and harsh environment. BN nanostructures possess good chemical inert and stability at high temperatures [22]. Therefore, increasing the hydrophobicity, and extending it to other boron nitride nanostructures, is a promising route toward industrial application. It is worth mentioning that to the best to the authors' knowledge, there are very few reports on super-hydrophobic BN coating and especially in the case of boron nitride nanosheets (BNNS). For instance, Pakdel et al. [14], have reported the effect of the synthesis temperature to increase the hydrophobicity of these nanostructures. The same authors have also reported the effect of boron nitride nanosheets hybridized with graphitic domains to fabricate super-hydrophobic nanosheets [23]. In this work, we present plasma treatment process to turn BNNS from hydrophobic to super-hydrophobic by means of low-pressure plasmas generated by electrical discharges in sulfur hexafluoride (SF₆) or tetrafluorethane (C₂H₂F₄) gas mixtures. Herein, the plasma treatment improved the hydrophobicity of BNNS treated with Ar/C₂H₂F₄ plasma, while it turned the BNNS to super-hydrophobic in the case of Ar/SF₆ plasma treatment. Indeed, the plasma treatments affected the surface chemistry as well as the

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nano/micro features of the BNNS surface. The results are analysed and discussed in context with wettability and surface chemistry/morphology properties of the plasma-modified BNNS. The plasma process, used in this work, is controllable, cheap, and scalable at the industrial level. The presented results are important for targeted utilization of BNNS as super-hydrophobic smart coating that can operate at high temperatures and harsh environment.

2. Experimental procedure

2.1. Boron nitride nanosheets (BNNS) synthesis

The BNNS were synthesised in a home-made CVD reactor. The Si/SiO₂ substrates were placed over an alumina combustion boat loaded with 30 mg of precursor powder (B:MgO:FeO in a 3:2:1 M ratio). This setup was loaded inside a closed-end quartz tube, and the whole setting was positioned in a horizontal tube furnace with the substrates facing upward. The precursor and substrate were then heated up to 1000 °C with an ammonia (NH₃) flow of 300 sccm for 30 min. All chemicals and reagents were used without any purification and were obtained from Sigma-Aldrich.

2.2. Plasma-treatment

The functionalization of BNNS surfaces was performed with low pressure plasmas generated in Ar/C₂H₂F₄ or Ar/SF₆ gas mixtures at fixed flow ratio. The samples were placed on the grounded electrode of a parallel-plate RF discharge. The functionalization conditions used in the present experiments were as follows: Ar to gas (C₂H₂F₄ or SF₆) flow ratio (in sccm) 10:25, pressure ≈ 10–20 Pa, RF power 40 W, and treatment time 10 min. The samples were treated with Ar/C₂H₂F₄ and Ar/SF₆ plasmas with fixed flow ratio.

2.3. Materials characterization

The samples were characterized under scanning electron microscope (SEM; JEOL 7500F) and transmission electron microscope (TEM; H9000-NAR, Hitachi). For TEM examination, the specimens were prepared by scratching the plasma-treated samples with a diamond tip and collecting the debris over a TEM copper grid covered with a thin holey carbon film. The TEM was operated at an accelerating voltage of 300 keV. Although the operating voltage is greater than the knock-on damage threshold of 74 and 84 keV for the B and N atoms, respectively [24], the BNNS were examined for very brief times and at reduced illumination to avoid any knock-on damage to the nanosheets. This approach has been reported to be quite effective in many earlier works [25, 26].

For surface chemical analysis, XPS measurements were carried out on K-Alpha (Thermo Scientific, East Grinstead, England) using a monochromatic (Al K_α)

X-ray beam, on a 300 × 300 μm² spot area in a spectrometer equipped with a flood gun for charge compensation. The C 1s line at 284.4 eV was used as a reference to correct the binding energies for charge energy shift. A Shirley background was subtracted from the spectra and the symmetric Gaussian functions were used during peak-fitting procedure.

The condensation experiments and contact angle measurements were made to determine wettability. The contact angle measurements were performed using a KSV CAM101 instrument consisting of a single compact unit equipped with FireWire video camera of 640 × 480 pixels resolution, a test stand, a standard syringe and an LED source. The contact angles were measured using a wetting liquid. The experiments were performed at room temperature by placing a drop of about 1 μL of distilled water on the surface. All the experiments were carried out few days after plasma-assisted treatment of the BNNS samples.

3. Results and discussion

The top view scanning electron micrographs (SEM), that show the surface morphologies of the as-deposited BNNS and BNNS after plasma treatment, are presented in Fig. 1. The as-deposited BNNS (Fig. 1a) are noticed to exhibit highly bent and crumpled structural morphology. Indeed, the BNNS appear to be irregularly shaped with lateral surface area. Upon plasma treatment with Ar/C₂H₂F₄ (Fig. 1b), there is a clear apparent change in the surface morphology of the treated BNNS. The BNNS are covered with a conformal thin film (probably a fluorocarbon layer) after the treatment in Ar/C₂H₂F₄, which conducts to the increase of the walls dimension. Moreover, when the wall's edges are being rounded, we observe that the deposited film tend to cover the walls. The surface morphology of SF₆ plasma treated BNNS is presented in Fig. 1c. The most significant modification observed upon SF₆ plasma exposure is the quality of the SEM images, which becomes more blurred with less morphological details and some damage of the edges, most probably because of surface charging effects due to attachment of fluorine-related radicals onto the BNNS.

For better examination of the surface morphology of the BNNS before and after plasma treatment, TEM measurements were performed, as shown in Fig. 2. The low magnification micrograph in Fig. 2a shows BNNS with bending and scrolling morphology at or near their edges. High-resolution TEM (HRTEM) images, from rectangular region of Fig. 2a (Fig. 2b) show highly ordered lattice fringes, indicating that the BNNS are crystalline with high purity. The spacing between adjacent fringes is around ~ 0.34 nm, which is characteristic of the (002) inter-planar distance of h-BN [27]. The HRTEM image of BNNS after Ar/SF₆ plasma treatment is shown in Fig. 2c. It reveals that the surface is covered by a kind of amorphous layer with a thickness

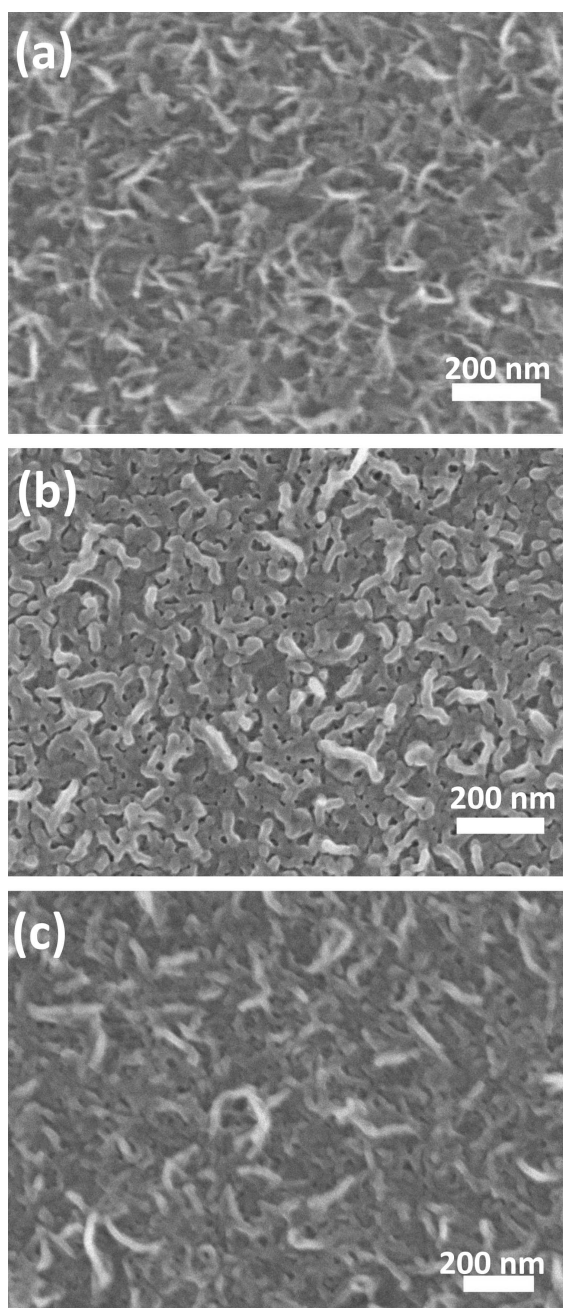


Fig. 1. Top view SEM micrographs of (a) as-prepared BNNS, (b) treated with Ar/C₂H₂F₄ plasma and (c) treated with Ar/SF₆ plasma.

of around 1 nm, which appears, as shown with the arrows to be turbostratic BN (t-BN). This indicates a surface damage and etching of BNNS surface in a good agreement of SEM image (Fig. 1c). Figure 2d shows HRTEM image of BNNS after Ar/C₂H₂F₄ plasma treatment. In this case, it is clear that the walls are entirely covered by a coating layer which appears to be amorphous. The layer thickness is around 5 nm (as shown in the inset image) and it is believed to be fluorocarbon layer which confirms the SEM observation (Fig. 2a).

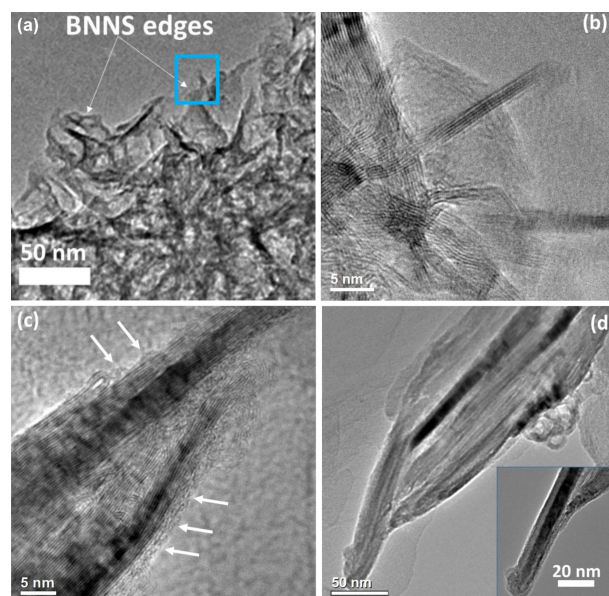


Fig. 2. (a) Low-magnification TEM image of the BNNS synthesized at 1000 °C, (b) HRTEM image of BNNS without plasma treatment (of the rectangular region in Fig. 2 a), (c) HRTEM image of BNNS after treatment with Ar/SF₆ plasma, (d) HRTEM image of BNNS after treatment with Ar/C₂H₂F₄ plasma, with inset showing deposition of fluorocarbon layer on the wall.

XPS survey spectra analyses (shown in Fig. 3) were performed on as-prepared and plasma-treated BNNS, with the aim at investigating the surface chemistry of BNNS after plasma treatment. In the case of untreated sample (Fig. 3a), the spectrum shows the presence of carbon (C), nitrogen (N), boron (B), and oxygen (O) elements. The constituent elements, which are B and N, are represented by their respective intense lines. The C and O elements with low intensity comes from surface contamination or/and defects. It is worth to mention that, the very low intensity of O 1s peak indicates high purity of the as-deposited BNNS. The survey spectrum of BNNS treated with Ar/SF₆ plasma (Fig. 3b) shows the presence of additional and intense peak that is related to fluorine element (F 1s), but without any signature of sulfur element. Furthermore, it can be noticed that there is an increase of O 1s peak compared with the as-deposited BNNS and a decrease of N 1s and B 1s related intensities. This can be attributed to the extensive surface oxidation due to Ar/SF₆ plasma treatment in a good agreement with TEM observation (Fig. 2c). In the case of Ar/C₂H₂F₄ plasma the survey spectrum is completely different. One can notice only the presence of fluorine element (F 1s) and carbon element (C 1s) with very low intense O 1s related peak, but without any trace of nitrogen or boron elements. This collaborates well with the TEM observation (Fig. 2d) and confirms that the BNNS surface is completely covered with fluorocarbon layer.

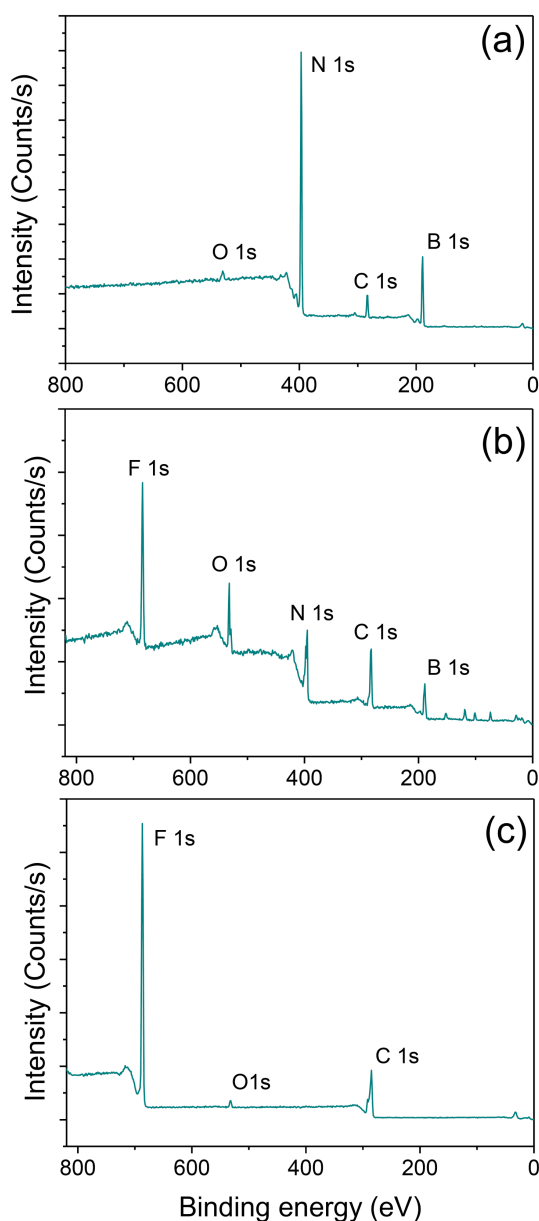


Fig. 3. XPS survey spectra of BNNS (a) before and (b) after plasma treatment in (b) Ar/SF₆, and (c) Ar/C₂H₂F₄.

The deconvoluted high resolution B 1s of the as-prepared and plasma-treated BNNS samples are presented in Fig. 4. The B 1s spectrum of the as-made sample (Fig. 4a) can be decomposed into two peaks, the intense one at ~ 190.0 eV is attributed to BN bonds in h-BN [28–30] and the second one at ~ 190.8 eV can be assigned to boron atoms simultaneously bonded to oxygen and nitrogen (N-B-O) [28, 29]. After Ar/SF₆ plasma treatment (Fig. 4b), the peak related to h-BN was noticed to completely disappear with the appearance of two new peaks, the first one at binding energy of 191.4 eV and can be assigned to B-F bond [31, 32] and a second new peak at 193.0 eV which can be assigned to

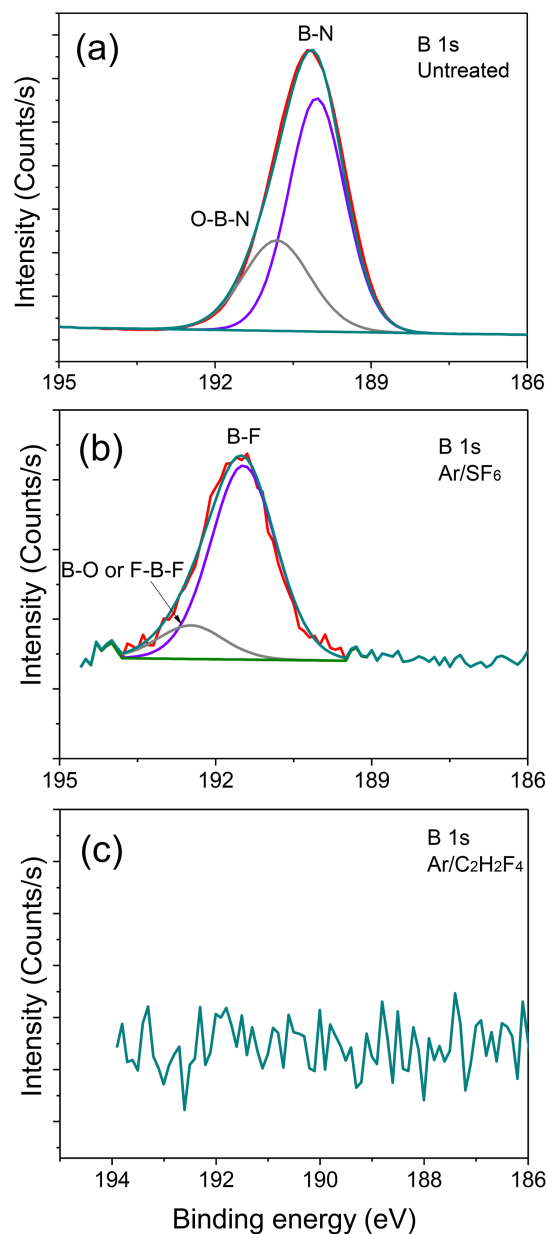


Fig. 4. High-resolution XPS spectra of the B 1s core level for BNNS samples (a) before, and after plasma treatment in (b) Ar/SF₆ and (c) Ar/C₂H₂F₄ plasmas.

B–O bond or F–B–F bond [28, 29]. This indicates that the surface of BNNS is completely oxidized/ fluorized after Ar/SF₆ plasma. In the case of Ar/C₂H₂F₄ plasma no trace for B 1s peak (Fig. 4c) was detected due to surface coverage with the fluorocarbon layer.

The N 1s spectrum of the as-prepared BNNS sample (Fig. 5a) can be fitted by two curves. The intense one at ~ 397.7 eV can be assigned to N–B bonds in h-BN [29, 33], whereas the other one centered at ~ 398.7 eV has been identified as a turbostratic structure (t-BN) attributed to the presence of N–O and/or N–OH bonds [29]. After treatment with Ar/SF₆ plasma, the BNNS sample showed a new peak positioned

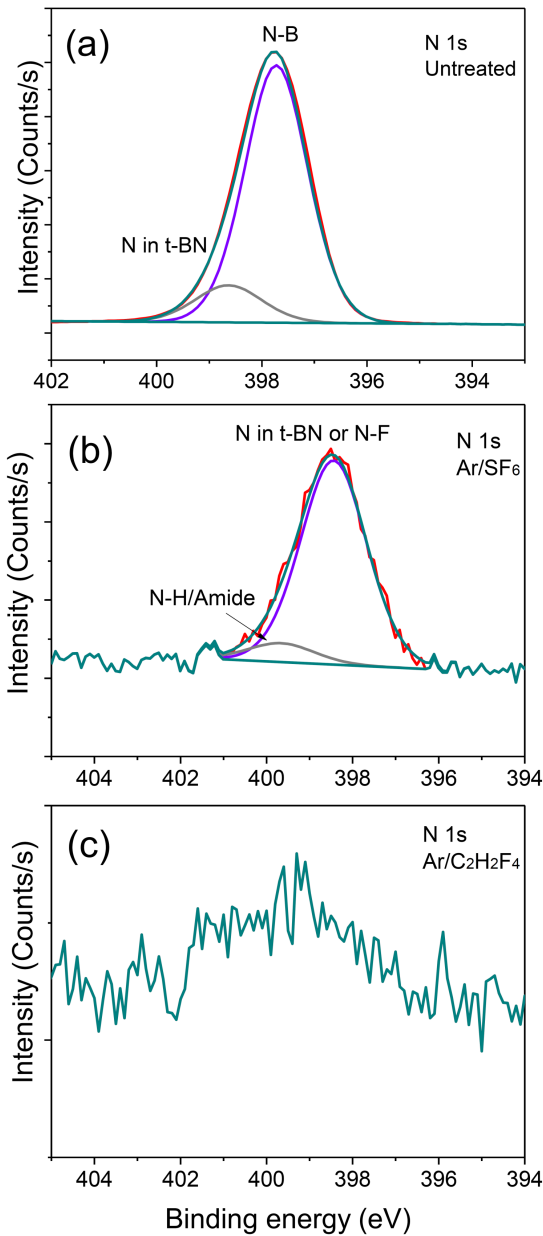


Fig. 5. High-resolution XPS spectra of the N 1s core level for BNNS samples (a) before, and after plasma treatment in (b) Ar/SF₆ and (c) Ar/C₂H₂F₄ plasmas.

at around 400.0 eV (Fig. 5b) formed due to presence of N–H bond [33] or amide group [29]. In addition, the peak related to B–N bond completely disappears while a peak that can be attributed to t-BN or N–F [31, 32] becomes the most intense. This t-BN is already observed in HRTEM of BNNS after Ar/SF₆ plasma covering the entire surface of BNNS walls. Again, the HRTEM are in accordance with the XPS analyses. In the case of Ar/C₂H₂F₄ plasma, the N 1s peak was not detected, because XPS is a surface characterization technique and fluorocarbon layer formed on the surface is thicker than the penetration depth of XPS analyses.

The F 1s core peak (Fig. 6a) obtained for BNNS treated with Ar/SF₆ plasma is characterized by a main component at 685.6 eV. This value is very close to F linked to metals like lithium [34]. Since we did not find any XPS report in literature for boron-fluorine bonds in the case of F 1s core level spectra, the main peak here could be assigned to F–B bond. The energy position of the F 1s in the BNNS treated with Ar/C₂H₂F₄ plasma, shown in Fig. 6b, is about 686.6 eV, which can be compared to 686.9 eV in poly(vinyl fluoride). Note, that F 1s signal in Viton and poly(tetrafluoroethylene) is at 688.8 and 689.67 eV, respectively. This comparison suggests that in our case a H–C–F species are likely to be present on the surface [35]. This supports our suggestion of fluorocarbon layer formation on the surface of BNNS treated with Ar/C₂H₂F₄ plasma.

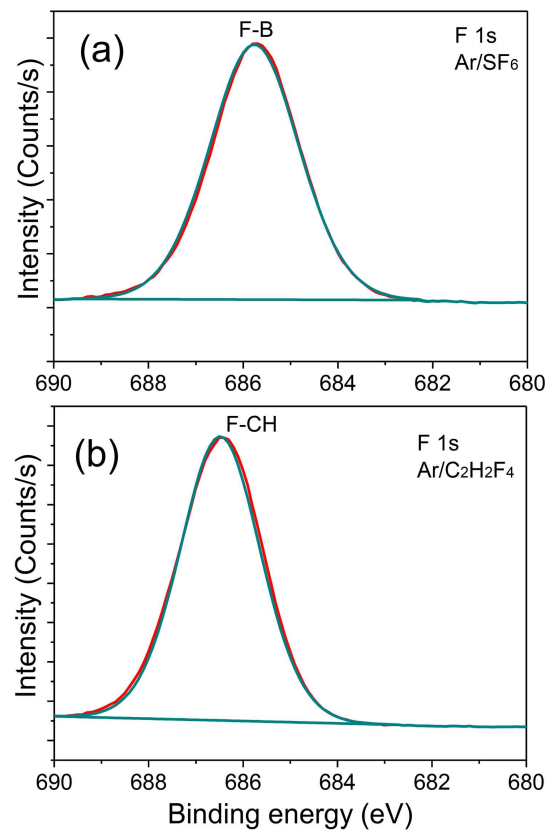


Fig. 6. High-resolution XPS spectra of the F 1s core level for BNNS samples after plasma treatment in (a) Ar/SF₆ and (b) Ar/C₂H₂F₄ plasmas.

Water contact angle (WCA) measurements were performed on all the samples, with the aim at assessing the effect of plasma treatment with Ar/SF₆ and Ar/C₂H₂F₄ plasmas on wetting characteristics of BNNS. The water contact angle (WCA) values of the as-prepared and plasma treated BNNS are shown in Fig. 7. The WCA values were noticed to increase from (118.2° ± 2.3°) for the as-deposited BNNS to (137° ± 1.4°) and (167.9° ± 1.8°) for the Ar/C₂H₂F₄ and Ar/SF₆ plasma

modified BNNS sample, respectively. This increase in the contact angle value reveals a relative change in the BNNS surface wettability from hydrophobic to highly hydrophobic and to super-hydrophobic in the case of plasma treatment in Ar/C₂H₂F₄ and Ar/SF₆, respectively. It is a well-known fact that water repellent tendency of a solid surface depends on two factors: (i) the surface chemistry and functionality, and (ii) the surface micro/nano morphological features (i.e., surface roughness) [14].

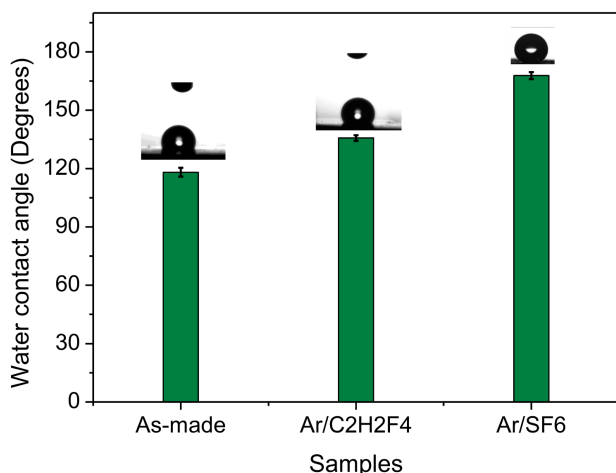


Fig. 7. Water contact angle measurements of the as-produced and plasma treated BNNS in C₂H₂F₄ and SF₆ plasmas. The insets are typical photographs showing water droplets on the BNNS surface.

In the present case, we can have the contribution of both effects. Indeed, the surface micro-roughness seems to increase in the case of Ar/C₂H₂F₄ plasma while it seems to be almost the same in the case of Ar/SF₆ plasma. Concerning the effect of surface chemistry (confirmed from XPS analysis), the presence of fluorocarbon layer on the surface of BNNS treated with Ar/C₂H₂F₄ plays a key role on the improvement of hydrophobicity. Indeed, the presence of such a layer and its effect on the increase of water repellency has already been reported in the case of carbon nanowalls [36] and carbon nanotubes [19]. In the case of treatment by Ar/SF₆ plasmas, there is a creation of new boron-fluorine bonds and radicals that could be the main agents for hydrophobicity enhancement and which may be even more hydrophobic than C-F bonds.

The cold plasma surface treatment is usually employed to render the BN based nanostructures hydrophilic [10, 12]. Indeed, to the best of the authors' knowledge, this is the first time the cold plasma treatment is used to increase the hydrophobicity of BN based nanostructures. In addition, the cold plasma process is cheap, controllable, and scalable, which makes it promising tool at the industrial level. In addition, although, Ar/C₂H₂F₄ plasma treatment did not induce a considerable increase of hydrophobicity, but fluorinated coatings are well

known to create low energy [37], biocompatible [38], or relatively inert surfaces with ambient air [39]. Therefore, coating BNNS with fluorinated coatings can find applications in biomedical cases, while super-hydrophobic BNNS that were treated in Ar/SF₆ plasma can find applications in self-cleaning coating for harsh environment or oil-water separation equipment.

4. Conclusions

We have shown that the post-synthesis plasma treatments can change the BNNS morphology and surface chemistry upon plasma treatment with a gas mixture of Ar/SF₆ or Ar/C₂H₂F₄. The initial and treated states of BNNS were characterized by SEM, TEM, and XPS spectroscopy. The morphological modifications are caused by plasma erosion of the edges in the case of Ar/SF₆ plasma or by deposition of thin conformal films in the case of Ar/C₂H₂F₄ plasma. In addition, depending on the gas mixture used, the plasma treatment of BNNS leads to the formation of different functional groups such as fluoro-boron and fluoro-carbon on the surface. Regarding the effect of such treatments on wettability: Ar/C₂H₂F₄ treatment made BNNS more hydrophobic with an increase of water contact angle (WCA) from 118.2° to 137.0°, while Ar/SF₆ made BNNS super-hydrophilic with a WCA as high as 167.9°. The increase of WCA is mainly attributed to surface roughness increase in the case of Ar/C₂H₂F₄ plasma, while in the case of Ar/SF₆ it is believed that the surface chemistry modification is the main responsible factor for converting BNNS from hydrophobic to super-hydrophobic. The presented results are important for targeted utilization of BNNS as super-hydrophobic smart coating that can operate at high temperatures and harsh environment.

Acknowledgments

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